

CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			Docket No. 14463
Applicant(s): Haruo Sunakawa, et al.			
Serial No. 09/821,411	Filing Date March 29, 2001	Examiner S. Mulpuri	Group Art Unit 2812
Invention: METHOD OF MANUFACTURING A NITROGEN-BASED SEMICONDUCTOR SUBSTRATE AND A SEMICONDUCTOR ELEMENT BY USING SAME			
<p>I hereby certify that this <u>Response under 37 C.F.R. 1.116</u> (Identify type of correspondence)</p> <p>is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703 308 7722</u>)</p> <p>on <u>March 26, 2003</u> (Date)</p> <p>Lisa Fiumara (Typed or Printed Name of Person Signing Certificate)</p> <p><u>Lisa Fiumara</u> (Signature)</p>			
<p>Note: Each paper must have its own certificate of mailing.</p> <p>MAX RECEIVED MAR 28 2003 TELETYPE UNIT</p>			